

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : TBD
Applicant : Hidetoshi Oyama et al.
Filed : Herewith
Title : "ARC WELDING CONTROL UNIT"

Confirmation No. : TBD
TC/A.U. : TBD
Examiner : TBD

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Customer No. : 052054
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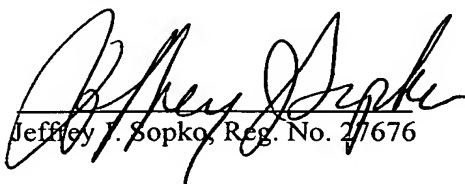
In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (ISR, copy enclosed) and in the enclosed copy of Patent Office Form 1449. Copies of the publications cited in the International Search Report are not enclosed as they were previously forwarded by the International Bureau, however, a copy of the publication cited in the specification is enclosed.

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Respectfully submitted,

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Hidetoshi Oyama et al.

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U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A						
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	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L	50-26344	03/1975	JAPAN			Cited on ISR
	M	59-77578	05/1984	JAPAN			Cited on ISR
	N	8-99182	04/1996	JAPAN			Cited on ISR
	P	8-214549	08/1996	JAPAN			Cited in Specification-English Abstract
	Q						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

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